



INTERNATIONAL
GEMOLOGICAL
INSTITUTE

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LABORATORY GROWN DIAMOND REPORT

August 25, 2026

IGI Report Number

LG825686790

Description

LABORATORY GROWN DIAMOND

Shape and Cutting Style

MODIFIED MARQUISE STEP CUT

Measurements

13.34 X 6.77 X 3.36 MM

GRADING RESULTS

Carat Weight

2.05 CARATS

Color Grade

F

Clarity Grade

VS 1

ADDITIONAL GRADING INFORMATION

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

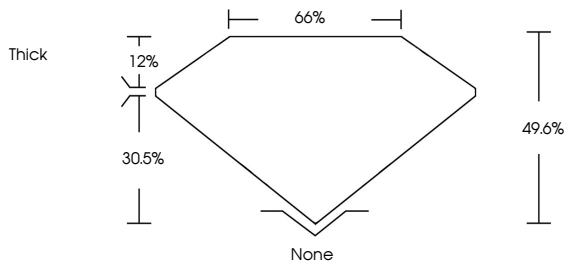
Inscription(s)

 LG825686790

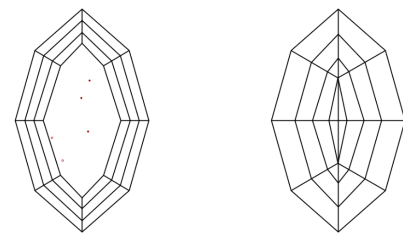
Comments: This Laboratory Grown Diamond was created by Chemical Vapor Deposition (CVD) growth process.
Type IIa

Report verification at igi.org

PROPORTIONS



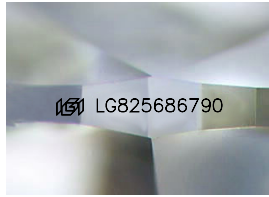
CLARITY CHARACTERISTICS



KEY TO SYMBOLS

Red symbols indicate internal characteristics.
Green symbols indicate external characteristics.

Sample Image Used



COLOR

FL D E F G H I J Faint Very Light Light

CLARITY

FL IF VVS 1-2 VS 1-2 SI 1-2 I 1-3

Flawless Internally Flawless Very Very Slightly Included Very Slightly Included Slightly Included Included

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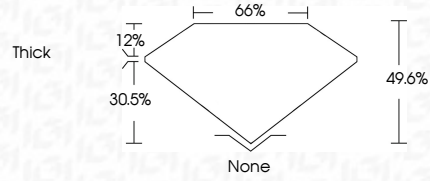
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IGI

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MODIFIED MARQUISE STEP CUT

13.34 X 6.77 X 3.36 MM

Carat Weight

2.05 CARATS

Color Grade

F

Clarity Grade

VS 1

Depth

49.6%

Table

65%

Girdle

Thick

Culet

None

Polish

EXCELLENT

Symmetry

EXCELLENT

Fluorescence

NONE

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